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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

December 5, 2025

IGI Report Number **LG755508021**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **6.33 X 6.26 X 4.52 MM**

GRADING RESULTS

Carat Weight **1.59 CARAT**

Color Grade **D**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG755508021**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

LG755508021
Report verification at igi.org

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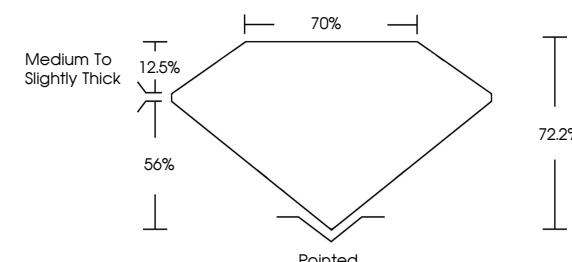
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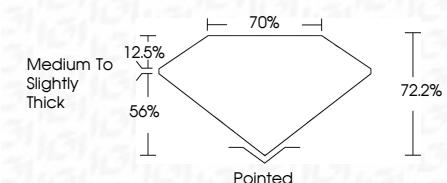
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	SI ¹⁻²	SI ¹⁻³	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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PRINCESS CUT

6.33 X 6.26 X 4.52 MM

1.59 CARAT

D

VVS 2

72.2%

70%

Medium To Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

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IGI